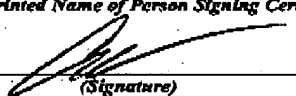


CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)			Docket No.
Applicant(s): Yoshiro TSURUGIDA			OKI.291
Serial No. 10/034,379	Filing Date 01/03/2002	Examiner DAVID NHU	Group Art Unit 2818
Invention: METHOD FOR SELECTIVELY OXIDIZING A SILICON WAFER			
<div style="text-align: right;">RECEIVED CENTRAL FAX CENTER MAY 10 2004 OFFICIAL</div>			
I hereby certify that this <u>SUPPLEMENTAL AMENDMENT</u> <small>(Identify type of correspondence)</small>			
is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. <u>703-872-9306</u>)			
on <u>MAY 10, 2004</u> <small>(Date)</small>			
<div style="text-align: center;"><u>ADAM C. VOLENTINE</u> <small>(Typed or Printed Name of Person Signing Certificate)</small>  <small>(Signature)</small></div>			
<p style="text-align: center;">Note: Each paper must have its own certificate of mailing.</p>			

P18/REV01

Serial No. 10/034,379

OKI.291

Amendment dated May 10, 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent application of :
Yoshirou Tsurugida : Group Art Unit 2818
Serial No. 10/034,379 : Examiner David Nhu
Filed January 3, 2002 :

METHOD FOR SELECTIVELY OXIDIZING A SILICON WAFER

RECEIVED
CENTRAL FAX CENTER

MAY 10 2004

OFFICIAL

SUPPLEMENTAL AMENDMENT

U.S. Patent and Trademark Office
2011 South Clark Place
Customer Window, Mail Stop Non-Fee Amendment
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

Sir:

Further to the Amendment filed March 24, 2004, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.